



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Watts, Michael P.C.
Appl. No.: 10/758,384 GPAU.: 1722
Filed: January 15, 2004 Examiner: G. Nagesh Rao
Docket No.: P78-20-03 Conf. No.: 5448
For: THERMAL PROCESSING SYSTEM FOR IMPRINT LITHOGRAPHY

AMENDMENT

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office action mailed 1 March 2006 with a three-month shortened statutory period for response of 1 June 2006 and extended hereby to 1 July 2006 by the enclosed Petition for Extension of Time, Applicants respectfully request that the application be amended as follows:

Amendments to the Claims begin on page 2 of this paper

Amendments to the Drawings begin on page 6 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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